

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q91474

Hideyuki OHTAKE, et al.

Appln. No.: Based on PCT/JP04/012613

Confirmation No.: Not yet assigned

Group Art Unit: Not yet assigned

Filed: February 27, 2006

Examiner: Not yet assigned

For: ELECTRIC-FIELD DISTRIBUTION MEASUREMENT METHOD AND APPARATUS
FOR SEMICONDUCTOR DEVICE

PRELIMINARY AMENDMENT

MAIL STOP AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Prior to examination, please amend the above-identified application as follows on the accompanying pages.

TABLE OF CONTENTS

AMENDMENTS TO THE CLAIMS	2
REMARKS	7